

Notice of References CitedApplication/Control No.
09/975,297Applicant(s)/Patent Under
Reexamination
OSSIPOV ET AL.Examiner
Ida M SowardArt Unit
2822

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,153,014	11-2000	Song	134/2
	C	US-			
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	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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